



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
 UNITED STATES PATENT AND TRADEMARK OFFICE  
 WASHINGTON, D.C. 20231  
 www.uspto.gov



CONFIRMATION NO. 1815

Bib Data Sheet

SERIAL NUMBER 10/014,855	FILING DATE 12/14/2001 RULE	CLASS 414	GROUP ART UNIT 3652	ATTORNEY DOCKET NO. 217406US2
-----------------------------	-----------------------------------	--------------	------------------------	-------------------------------------

## APPLICANTS

Masanori Tateyama, Kumamoto-Ken, JAPAN;  
 Akira Miyata, Kumamoto-Ken, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2000-380663 12/14/2000

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 01/14/2002

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature Initials				

## ADDRESS

22850

## TITLE

Substrate processing system and substrate processing method

FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-------------------------------	---	--